R SHEET

To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.			
1.	Name of Conveying party(ies): H. Bernhard Pogg	ge and Christopher P. Ausschnitt	
3.	Nature of Conveyance: Assignment	2. Name & address of receiving party(ies)	010
	Execution Date: 11/06/98; 11/10/98.	Name: International Business Machines Corporation	1720
	EXECUTION DAGE: 11/10/38, 11/10/38.	Street Address: New Orchard Road	7,13 113
		City: Armonk State: New York ZIP: 10504	09
4 .	Application number(s) or patent number(s):		5
	Title of Application: DOUBLE-SIDED WAFER EXPOSURE METHOD AND DEVICE.		
	If this document is being filed together with a new application, the execution date of the application is: $\frac{11/06/98}{11/10/98}$.		
	A. Patent Application No(s). Docket No. FI9-98-084	B. Patent No(s)	
	,	Additional numbers attached?Yes _X_No	
5.	Name and address of party to whom correspondence concerning document should be mailed:	6. Total number of applications and patents involved: 1	
	Name: Joseph P. Abate, Sr. Attorney		
	Street Address:		rged to
	International Business Machines Corp. Intellectual Property Law Dept. 1580 Route 52 Dept. 18G / Bldg. 300-482	deposit account 8. Deposit A/C no.: 09-0458 (FI-477)	
	Hopewell Junction, New York 12533		
	DO NOT USE THIS SPACE		
9.	Statement of signature:		
	To the best of my knowledge and belief, the fa true copy of the original document.	oregoing information is true and correct and any att	tached copy
	Joseph P. Abate, Reg. #30,238 Name of Person Signing Signa	1/-)2 -93	
	Telephone No. (914) 894-4633 Total number of pages including over she	et, attachments, and document: 2	
		RPOSITED WITH THE UNITED STATES POSTAL SERVICE AS EXPRESS S, WASHINGTON, D.C. 20231. THE APPLICANT AND/OR APTORNMY	60000000000000000000000000000000000000
	Name of Person Making Deposit: Robinann Zeno Signature: Kululuka Zeno 11/12/9	,8	
20.	/1996 JSHABAZZ 00000056 090458 09191720		

PATENT REEL: 9587 FRAME: 0732

(IBM Docket No.: FI9-98-084)

ASSIGNMENT

Whereas, We

(1) H. Bernhard Pogge City of Hopewell Junction
County of Dutchess and State of New York

(2) Christopher P. Ausschnitt City of Brookfield

County of Fairfield and State of Connecticut

have invented certain improvements in

Double-Sided Wafer Exposure Method And Device

and have executed, respectively, a United States patent application therefor on (1) Nov 6 1998 And (2) Nov 10 1998.

Whereas, INTERNATIONAL BUSINESS MACHINES CORPORATION, a corporation of New York, having a place of business at Armonk, New York 10504 (hereinafter called IBM), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents obtained therefor;

Now, therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I the above named hereby sell, assign, and transfer to IBM, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the invention set forth in said application to IBM, it successors and assigns; and I hereby agree that IBM may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by IBM.

(1) Signed at East Fishkill, NY

RECORDED: 11/12/1998

on 11-6-98

Signature
H. Bernhard Pogge

2) 11/(0/98)

Signature

Christopher P. Ausschnitt

PATENT REEL: 9587 FRAME: 0733